#10/ Amet S

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

applicants:

Yoshiyuki Tanaka et al.

Atty. Docket No.

075834.00111

Serial No.:

09/955,810

Group Art Unit:

2825

Filed:

September 19, 2001

Examiner:

Calvin Lee

Invention:

"PRODUCTION METHOD OF SEMICONDUCTOR DEVICE"

AMENDMENT A

AND PETITION FOR EXTENSION OF TIME

Commissioner for Patents Alexandria, VA 22313-1450

SIR:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one-month extension of time to respond to the outstanding Office Action under 37 C.F.R. §1.136(a). The time to respond is thus extended to May 3, 2003. Applicant has included a check in the amount of \$110.00 as payment of the required fee set forth in 37 C.F.R. §1.17(a).

In response to the Office Action dated January 2, 2003, please amend the application as follows:

05/12/2003 HGUTEMA1 00000028 09955810

01 FC:1251

110.00 OP